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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

of

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Complete if Known				
Application Number	09/905,662			
Filing Date	July 13, 2001			
First Named Inventor	Yasuhito Inagaki			
Art Unit	1746			
Examiner Name Michail Kornakov				
Attorney Docket Number 09792909-5081				

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (If known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
MK	1	US 5,976,988	11-02-1999	Konuma et al.	
MK	2	US 5,722,441	03-03-1998	Teramoto	

FOREIGN PATENT DOCUMENTS						
Examiner	Cite No.1	Foreign Patent Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or	Le
Initials*		Country Code ³ Number ⁴ Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Relevant Figures Appear	
MC	3	JP 60-114579	06-21-1985	Hitachi Ltd		
MK	4	JP 59-046032	03-15-1984	Hitachi Ltd		

OTHER ITEMS - NON PATENT LITERATURE DOCUMENTS				
Examine r Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s); publisher, city and/or country where published.	T ²	
MK	5	KASHKOUSH et al., "In-Situ Chemical Concentration Control for Wafer Wet Cleaning," Journal of the IEST, May/June 1998, pp. 24-30.		

Examiner Signature	who	Date Considered	02/07/06
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unquie citation designation number (optional). 2 See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

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